

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/621,049	LIU, HENG	
Examiner	Art Unit	
Ram N. Kackar	1763	

	SEARCHED				
Class	Subclass	Date	Examiner		
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INI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
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